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(Use as many sheets as necessary)

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Complete if Known	
Application Number	10/525824
Filing Date	01/17/2008
First Named Inventor	David L. Bender
Art Unit	1722
Examiner Name	
Attorney Docket Number	SOLAICX 004

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.[1]	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T[2]
	1	C. WANG et al.; A Continuous Czochralski Silicon Crystal Growth System; Journal of Crystal Growth 250 (2003), pgs. 209-214	
	2	HOPKINS et al.; Crystal Growth Considerations in the Use of "Solar Grade" Silicon; Journal of Crystal Growth 42 (1977) 493-498	
	3	M. H. LEIPOLD et al.; Materials of Construction for Silicon Crystal Growth; Journal of Crystal Growth 50 (1980) 366-377	
	4	T. F. CISZEK et al.; Silicon Materials Research on Growth Processes, Impurities, and Defects; NREL Conference March, 2003	
	5	T. WANG; Shallow Melt Czochralski Growth of Semiconductor Silicon; NREL, Golden, CO; Aug. 5, 2003	

Examiner Signature		Date Considered	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

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